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8-20-01
R. Atkinson

11002 U.S. PTO
09/836182
04/18/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Rule 53(b) Divisional Application of:

Fumihiko TANIGUCHI et al.

Serial No.: Div. of 09/335,878

Prior Group Art Unit: 2822

Filed: June 18, 1999

Examiner: M. WILCZEWSKI

For: METHOD OF FABRICATING SEMICONDUCTOR HAVING THROUGH HOLE

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Director of Patents and Trademarks
Washington, D.C. 20231

April 18, 2001

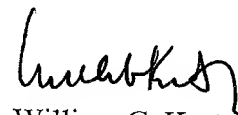
Sir:

This Information Disclosure Statement is being filed in order to comply with Applicant's duty of disclosure under 37 CFR 1.56. The documents listed on the Form PTO-1449 were made of record in grandparent application Serial No. 09/123,450 filed on July 28, 1998.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

ARMSTRONG, WESTERMAN, HATTORI,
McLELAND & NAUGHTON, LLP



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Enclosures: PTO-1449



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **TANIGUCHI, et al.**

Serial No.: **09/836,182**

Filed: **April 18, 2001**

Group Art Unit: **2827**

Examiner: **MITCHELL, James M.**

P.T.O. Confirmation No.: **7961**

For. **METHOD OF FABRICATING SEMICONDUCTOR HAVING THROUGH HOLE**

INFORMATION DISCLOSURE STATEMENT AND STATEMENT
PURSUANT TO 37 CFR 1.97(d)

Commissioner for Patents
Washington, D.C. 20231

Attn: **Group Director**

January 6, 2003

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

This Information Disclosure Statement is submitted after the mailing of a final action, a Notice of Allowance, or an action that otherwise closes prosecution in the application, but on or before payment of the Issue Fee.

The undersigned hereby certifies that each item of information contained in this statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

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The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

A check is attached hereto which covers the \$180.00 fee set forth in 37 CFR § 1.17(p). The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this Statement to our Deposit Account No. 01-2340. Two copies of this authorization are attached.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP



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PATENT TRADEMARK OFFICE

Enclosure: \$180.00 fee
Four (4) References